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EXCERMILE INDIVIDUAL SINCE	SIMILE TRANSMITTAL SHEET
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TO: Examiner CHRISTOPHER G. YOUNG
Group Art Unit 1756

COMPANY:
United States Patent and Trademark Office

FAX NUMBER:
571-273-8300

FROM: Kenneth C. Brooks
Reg. No. 38,393

DATE:
August 2, 2005

TOTAL NO. OF PAGES INCLUDING COVER:
21

RE:

INFORMATION DISCLOSURE STATEMENT

U.S. Patent Application No. 10/781,278

Filing Date:

February 18, 2004

Entitled:

Imprint Lithography Template Having a Mold to Compensate for Material Changes of an

Underlying Liquid

Our Ref. No.: PA95-37D13

Please see attached:

Information Disclosure Statement: Transmittal (2 pg(s)), Form PTO/SB/08A (3 pgs) copies of 3 cited references (15 pg(s))

KCB:kep

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PAGE 1/21 * RCVD AT 8/2/2005 10:41:34 AM [Eastern Daylight Time] * SVR:USPTO-EFXRF-6/24 * DNIS:2738300 * CSID:5124918918 * DURATION (mm-ss):06-36

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:

Bailey, Todd C.

App. No.:

10/781,278

GPAU:

1756

Filing Date:

02/18/2004

Examiner:

Christopher G. Young

Dkt. No.:

PA95-37D13

Conf. No.:

2060

For: Imprint Lithography Template Having a Mold to Compensate

for Material Changes of an Underlying Liquid

INFORMATION DISCLOSURE STATEMENT

Mail Stop AMENDMENT Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

The following information is submitted in compliance with Applicants' duty of disclosure and pursuant to 37 C.F.R. § 1.56, § 1.97 and § 1.98. The undersigned brings the patents, publications, applications or other information identified in the attached:

\boxtimes	Form(s)	PTO/SB/08A	and/or	PTO/SB/08B	or	PTO/1449
	Other:					

to the Examiner's attention in the above-identified application. It is respectfully requested that the cited information be expressly considered during the prosecution of this application, and the references be made of record therein and appear among the "references cited" on any patent to issue therefrom.

This Information Disclosure Statement is being filed:

before the mailing date of a first Office action on the merits or before the mailing date of a first Office action after the filing of a request for continued examination under § 1.114. Therefore, no fee is believed required.

Applicants do not believe that any additional fees are due, but if the Commissioner believes additional fees are due, the Commissioner is hereby authorized to charge any fees which may be required, or credit any overpayment, to Deposit Account Number 502650.

CERTIFICATE OF TRANSMISSION
I hereby certify that this correspondence is being facsimile transmitted to the USPTO or deposited with the United States Postal Service with sufficient postage as either First ClassMail or Express Mail, in an envelope addressed to the Commissioner for Patents.

Signed:____

Typed Name: Katrina Prati

Date

8-2-05

Respectfully Submitted,

Kenneth C. Brooks,

Reg. No. 38,393

IP Counsel

Legal Department

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PTO/SB/08A (08-03)

Approved for use through 7/31/2006. OMB 0651-0031

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Substi	ute for form 1449	A/PTO		Complete if Known		
	INFORMATION STATEMENT			APPLICATION NUMBER	10/781,278	
	SIAICHEN	DIAFFLI	CAUTI	FILING DATE	02/18/2004	
	(use as many sha	eets as necessa	ury)	FIRST NAMED INVENTOR	Sreenivasan et al.	
		1 .		Group Art Unit	1756	
Sheet	1	of	3	Examiner Name	Christopher G. Young	
		<u>. </u>		Attorney Docket Number	PA95-37D13	

				U.S. PATENT DOCUMEN	TS	
Examiner Initials*	Cite No.1	U.S. Patent Doo Number	ument Kind Code ² (ii known)	Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Unes, Where Relevant Passages or Relevant Figures Appear
 -	C1	5,206,983		Guckel et al.	5/4/1993	
•••	C2	5,669,303		Maracas et al.	9/23/1997	
	C3	6,117,708		Wensel	9/12/2000	
	Ç4	6,316,290		Wensel	11/13/2001	
	C5	6,190,929		Wang et al.	2/20/2001	
	C6	2005/0051698		Sreenivasan et al.	3/10/2005	•
- "	C7	2005/0084344		Bailey et al.	3/24/2005	
	C8	2005/0067379		Sreenivasan et al.	3/31/2005	
	Сэ	2004/0250945		Zheng et al.	12/16/2004	
	C10	5,477,058		Sato	12/19/1995	
	C11	2005/0084804		Truskett et al.	4/21/2005	
	C12	2005/0037143		Chou et al.	2/17/2005	
	Ç13	2005/0098534		Sreenivasan et al.	5/12/2005	
	C14	6,900,881		Sreenivasan et al.	5/31/2005	
	C15	6,902,853		Sreenivasan et al.	6/7/2005	
	C16	6,890,688		Mancini et al.	5/10/2005	
	C17	6,908,861		Sreenivasan et al.	6/21/2005	

Examiner	Date	
Signature	. Conside	red
Signature	·	100

*Examiner: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant. ¹ Applicant's unique citation designation number (optional). ² See Kinds Codes of USPTO Patent Documents at www.usplo.gov or MPEP 901.04. ³ Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ° For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ³ Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST.16 if possible. ° Applicant is to place a check mark here if English language Translation is attached.

This collection of information is required by 37 CFR 1.97 and 1.98. The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to process) an application. Confidentiality is governed by 35 U.S.C. 122 and 37 CFR 1.14. This collection is estimated to take 2 hours to complete, including gathering, preparing, and submitting the completed application form to the USPTO. Time will vary depending on the Individual case. Any comments on the amount of time you require to complete this form and/or suggestions for reducing this burden, should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, P.O. Box 1450, Alexandria, VA 22313-1450.. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND TO: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

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PTQ/\$B/08A (08-03)

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Substitute (or form 1449 <i>F</i>	VPTO .		Complete if Known		
	IFORMATIO			APPLICATION NUMBER	10/781,278	
	MILWENT	DIACCE	OANI .	FILING DATE	02/18/2004	
(u	se as many she	ets as necessa	ry)	FIRST NAMED INVENTOR	Sreenivasan et al.	
<u></u>				Group Art Unit	1756	
Sheet	2	of	3	Examiner Name	Christopher G. Young	
				Attorney Docket Number	PA95-37D13	

				U.S. PATENT DOCUMEN	TS	
Examiner Initials*	Cite No.1	U.S. Patent t	Nind Code ² (if known)	Name of Patentes or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Pussages of Relevant Figures Appear
	C18	6,916,584		Sreenīvasan et al.	7/12/2005	
	C19	6,921,615		Sreenivasan et al.	7/26/2005	
	C20	6,916,585		Sreenivasan et al.	7/12/2005	
	C21	6,919,152		Sreenivasan et al.	7/19/2005	
• • •				×		
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Examiner Signature	Date Considered	

*Examiner: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant. Applicant's unique citation designation number (optional). See Kinds Codes of USPTO Patent Documents at www.uspto.gov or MPEP 901.04. Enter Office that issued the document, by the two-letter code (WIPO Standard ST-3). For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. 5 Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST.16 if possible. 6 Applicant is to place a check mark here if English language Translation is attached.

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Under the Paperwork Reduction Act of 1995, no persons are required to respond	U.S. Patent and Trademark Office; U.S. DEPARTMENT OF COMMERCE 1 to a collection of information unless it displays a valid OMB motion number.

Substitu	te for form 1449A/F	то		Comple	Complete if Known		
	INFORMATION STATEMENT B			APPLICATION NUMBER	10/781,278		
	SIMICHICALD	TAPPLIC	MIA I	FILING DATE	02/18/2004		
	(use as many sheets	as necessary	v)	FIRST NAMED INVENTOR	Sreenivasan et al.		
				Group Art Unit	1756		
Sheet	3	of	3	Examiner Name	Christopher G. Young		
				Attorney Docket Number	PA95-37D13		

Cite No.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s),	Ιт
	publisher, city and/or country where published.	L
G22	SHIBUICHI ET AL., Super Water- and Oil-Repellent Surfaces Resulting from Fractal Structure, Journal of Colloid and Interface Science, Vol. 208, no. 1, pp. 287-294 12/1/1998	
C23	APPLICATION NO. 10/917,761, naming Inventors McMackin et al., entitled A Moat System for an Imprint Lithography Template, filed 8/13/2004	\uparrow
C24	TANIGUCHI ET AL., Diamond Nanoimprint Lithography, Nanotechnology, 2002, vol. 13, no. 5, pp. 592-596(5) 1/1/2002	†
C25	KIYOHARA ET AL., Abstract of Plasma Etching of CVD Diamond Films using an ECR-type Oxygen Source, http://www.iop.org/EJ/abstract/0957-4484/10/4/304 9/26/2003	\dagger
C26	APPLICATION NO. 11/126,948, naming Inventors Choi et al., entitled Formation of Discontinuous Films During an Imprint Lithography Process, filed 5/11/2005	1
C27	APPLICATION NO. 11/127,041, naming Inventors Sreenivasan et al., entitled Step and Repeat Imprint Lithography Processes, filed 5/11/2005	†
C28	APPLICATION NO. 11/127,060, naming Inventors Sreenivasan et al., entitled Step and Repeat Imprint Lithography Systems, filed 5/11/2005	†
C29	APPLICATION NO. 11/136,897, naming Inventors Miller et al., entitled Imprint Lithography Template Having a Coating to Reflect and/or Absorb Actinic Energy, filed 5/25/2005	†
	C23 C24 C25 C26 C27 C28	Journal of Colloid and Interface Science, Vol. 208, no. 1, pp. 287-294 12/1/1998 APPLICATION NO. 10/917,761, naming Inventors McMackin et al., entitled A Moat System for an Imprint Lithography Template, filed 8/13/2004 TANIGUCHI ET Al., Diamond Nanoimprint Lithography, Nanotechnology, 2002, vol. 13, no. 5, pp. 592-596(5) 1/1/2002 KIYOHARA ET AL., Abstract of Plasma Etching of CVD Diamond Films using an ECR-type Oxygen Source, http://www.iop.org/EJ/abstract/0957-4484/10/4/304 9/26/2003 APPLICATION NO. 11/126,946, naming Inventors Choi et al., entitled Formation of Discontinuous Films During an Imprint Lithography Process, filed 5/11/2005 APPLICATION NO. 11/127,041, naming Inventors Sreenivasan et al., entitled Step and Repeat Imprint Lithography Processes, filed 5/11/2005 APPLICATION NO. 11/127,060, naming Inventors Sreenivasan et al., entitled Step and Repeat Imprint Lithography Systems, filed 5/11/2005 APPLICATION NO. 11/136,897, naming Inventors Miller et al., entitled Imprint Lithography APPLICATION NO. 11/136,897, naming Inventors Miller et al., entitled Imprint Lithography

Examiner Signature	Date Considered	

*Examiner: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

Applicant's unique citation designation number (optional). Applicant is to place a check mark here if English language Translation is attached. This collection of information is required by 37 CFR 1.97 and 1.98. The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to process) an application. Confidentiality is governed by 35 U.S.C. 122 and 37 CFR 1.14. This collection is estimated to take 2 hours to complete, including gathering, preparing, and submitting the completed application form to the USPTO. Time will vary depending on the individual case. Any comments on the amount of time you require to complete this form and/or suggestions for reducing this burden, should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, P.O. Box 1450, Alexandria, VA 22313-1450.. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND TO: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

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